

FIG.

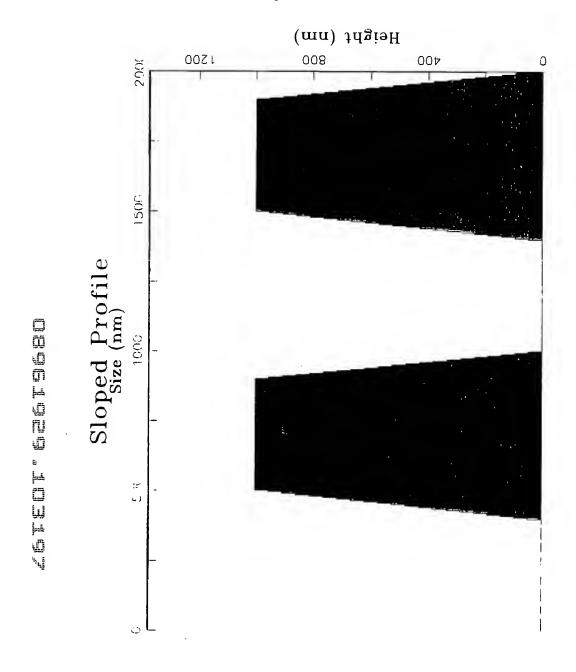
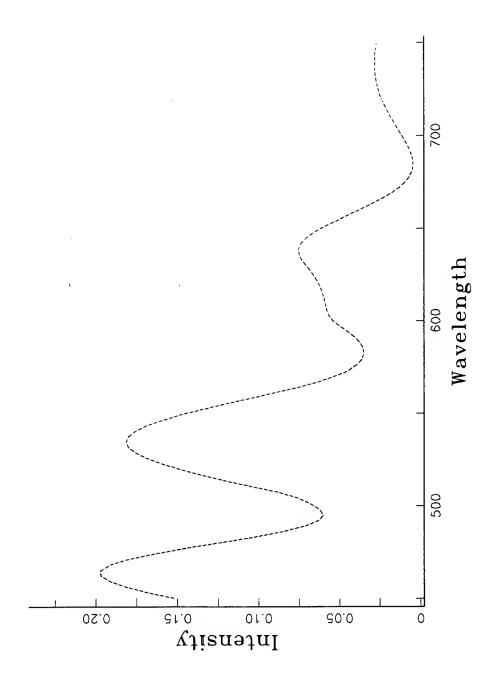
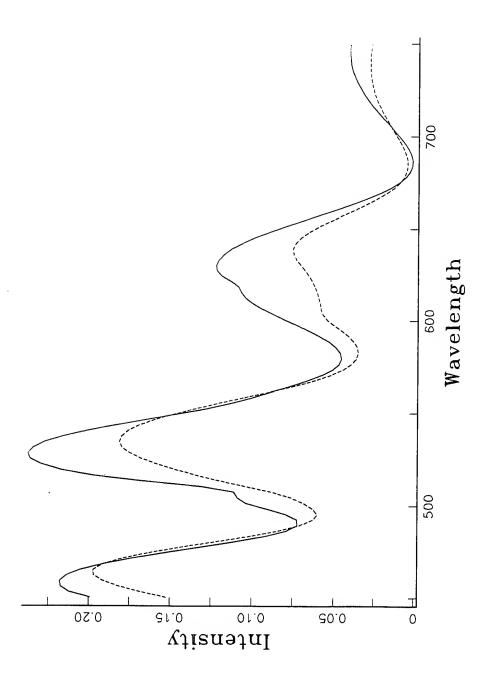


FIG. 1





<sup>.</sup>IG. 6

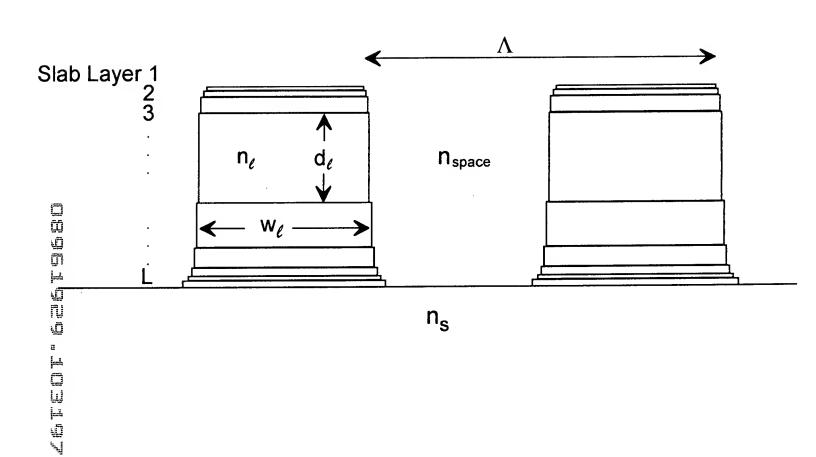


FIG. 7

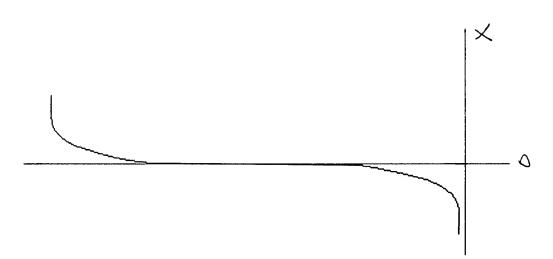


FIG. 8

FIG. 8b

FIG. 86



TOP SEED





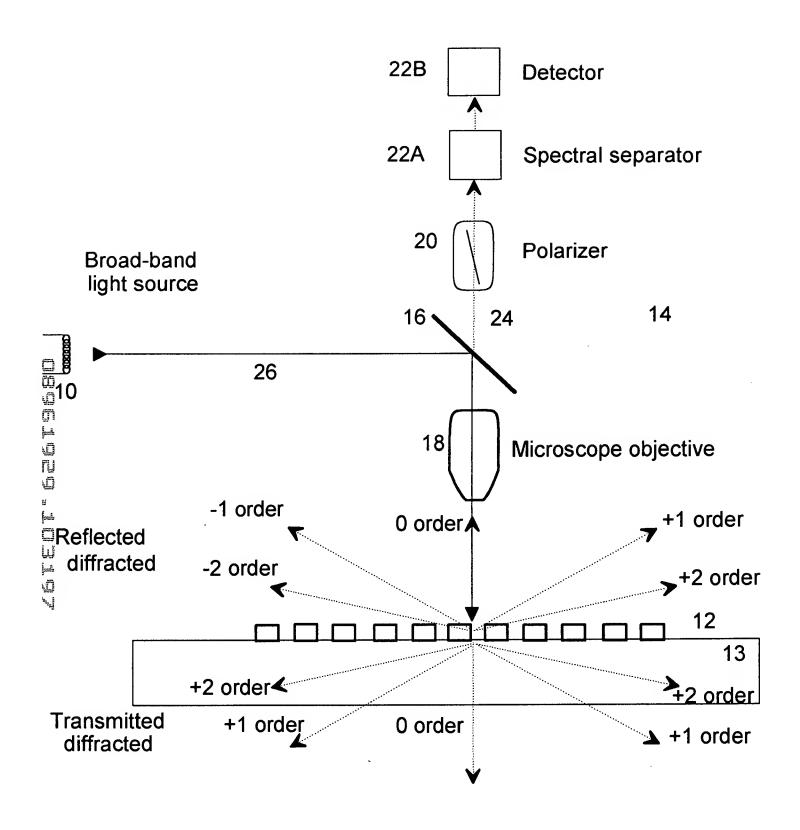


FIG. 9

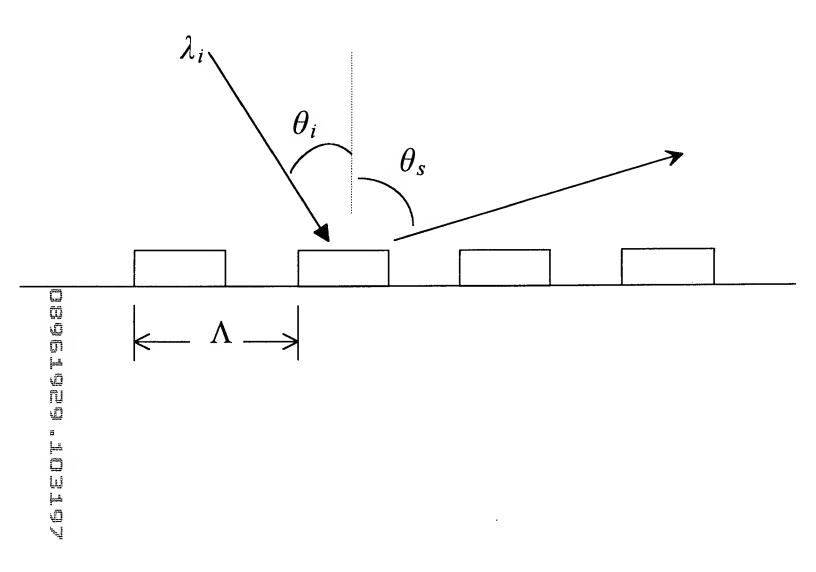


FIG. 10



```
COUPLEDRAVE RL; TT; DP
[0]

    Set ORDERS = the number of +diffracted orders retained.

[1]
        WAVELENGTH←WL
[2]
        C+LAYER[;2] * GRATINGPERIOD
                                                   n Determine f from dimensions
[3]
                                                   n Layer thicknesses
[4]
        d \leftarrow LAYER[;3]
                                                  n Index of air
n Angle of incidence, degrees
[5]
        n0 ←1
        THETA \leftarrow TH
[8]
                                                   o Incidence angle, radians
        THET \leftarrow THETA \times 0.1 \div 1.80
[7]
        ns+SIINDEX RAVELENCTH
                                                   n Determine the substrate index
[8]
[9]
        n \leftarrow 0 \rho 0
        FILMINDEX LAYER[;1]
                                                  a Determine the FILM index
[ 10 ]
                                                  n N will always be odd
[11]
        N+1+ORDERS\times 2
                                               I_{1} \leftarrow (1N) - 1
[12]
        i \leftarrow h - ((N-1) = 2)
[13]
[14] n
        I \leftarrow DD \leftarrow (N,N) \rho O
[15]
        TT \leftarrow (N,N) \rho + N
[16]
        T[(0=,(TT-\nabla TT))/(N+2)]
[17]
        I \leftarrow (\rho f) \rho \subset (\rho DD) \rho I
                                                  n I is the identity matrix
[18]
[19]
        IL \leftarrow 1 \supset I
[20]
        k0+02 #WAVELENGTII
        k \times i + k0 \times (n0 \times 10 THET) - i \times RAVELENGTH + GRATINGFERIOD
[21]
        k1zi + ((-(TT<0) \times 2)+1) \times (TT + ((k0+2) \times (n0+2)) - (k \times i + 2)) * .5
[22]
        k2\pi i + (((k0*2) \times (n\pi + 2)) - (k \times i * 2)) + .5
                                                                    n Absorbing substrate (Si)
[23]
[24] TM:
        B · ((K+.×"(EE·目"E·FERMITTIVITY))+.×"K·WAVENUMBER)-"I
[25]
[26] OPERTM+0
[27] n + TE
       EIGENSTUFF E+.×"B
                                                 n TM eigenspace calculations
[28]
                                                 n PRODUCT MATRIX FOR TM (EE IS B"E)
[29]
        V \leftarrow (EE + \cdot \times "R') + \cdot \times "Q'
                                                 A d SCALAR OR VECTOR WITH LENGTH OF f
        X \leftarrow I \times " \star - k0 \times "Q \times d
[30]
        DELTA \leftarrow ((2 \times N), 1) \rho (i=0), ((20THET) \times 0.71 \div n0) \times i=0
                                                                                    n FOR TM
[31]
        Z1 \leftarrow (1 \supset I) \times (N, N) \rho k1 \pi i + ((n0 \times 2) \times k0)
[32]
[33]
        Z2 \leftarrow (1 \supset I) \times (N, N) \cap k2 \times i : ((ns*2) \times k0)
        M1 \leftarrow IL, [1] \sim 0J1 \times 71
[ 34 ]
        FG+(1⊃I).[1]0J1×Z2
FANDG "Φιρί
[35]
[36]
[37]
        R \leftarrow N + \cdot (-DELTA)用(M1 \cdot -EG)
                Diffraction efficiency for TM
[38] n
       - DERTM+(THETAQUT=TH)/(DERTM=0)/DERTM+(R×+R)×90(k1zi+k0×n0×20THET)
[40] a PERTM+(DERTM=0)/DERTM+(R×+R)×90(b1si+k0×n0×20THET)
[41] n
       DERTE \leftarrow 0
[42]
[43]
        \rightarrow COMB
[ 0.9 ] TE:
       A \leftarrow (K + . \times K) + K
[45]
        ELGENSTUFF A
                                                 n TE eigenspace calculations
[46]
                                                 A FRODUCT MATRIX FOR TE
[47]
        V+W+...\times Z^{-1}Q
        X+I\times"*-k0\times"Q\times d
                                                 n d SCALAR OR VECTOR WITH LENGTH OF f
[48]
        DELTA \leftarrow ((2 \times N), 1) \rho (i = 0), ((20THET) \times 0.11 \times n0) \times i = 0
                                                                                     n FOR TE
[49]
        Y1+(1\supset I)\times (N,N)\cap k1\pi j + k0
[50]
        Y2 \leftarrow (1 \supset I) \times (N, N) \rho k2z i \neq k0
[51]
[52]
        M1 \leftarrow IL, [1] 0J1 \times Y1
        FG \leftarrow (1 \supset I), [1]0 \downarrow 1 \times Y2
[53]
        FANDG" PIPE
[54]
        R \leftarrow N + (-DELTA) \oplus (M1, -FG)
[55]
                      Diffraction efficiency for TE
[56] n
        DERTE+(THETAQUT=TH)/(DERTE+0)/DERTE+(R×+R)×90(k1zi+k0×n0×20THET)
[57]
[58] COMB:
        CURVE ← CURVE, [1]1 3 p WAVELENGTH, DERTE, DERTM
```

## FIG. 11(cont'd)



```
[60] aCURVE+CURVE.[1]1 3pRAVELENGTH.DERTM.DERTE
              EIGENSTUFF EI
    \Gamma O I
    [1]
              Z \cdot EIGEN"EI
                                           n The function EICEN is an IBM program product
             K \leftarrow ((\rho f) \rho \leq 1 \ 0) + \mathbb{Z} of and cannot be shown here. QQ \leftarrow ((\rho f) \rho \leq ((-N), 0)) + \mathbb{Z}
    [2]
    [3]
    [4]
              Q \leftarrow 0 \rho 0
              ELGENVALUE"QQ
    [5]
              Q \leftarrow Q \times I
    [6]
    [0]
             EIGENVALUE QQ
              Q \leftarrow Q \leftarrow (N \cdot N) \rho Q Q + .5
    [1]
             FANDG L; XA: XL: WL: VL
    [0]
    [1]
             XL \leftarrow L \supset X
    [2]
             WL + L \supset W
    [3]
             VI_{r} \leftarrow I_{r} \supset V
             AB \leftarrow (B((-RL), [1]VL), FG) + . \times (RL + . \times XL), [1]VL + . \times XL
    [4]
    [6]
             A \leftarrow (N, N) \rho A B
              FG \leftarrow (WL + . \times IL + XA), [1] WL + . \times IL - XA \leftarrow XL + . \times A
    [7]
             FILMINDEX FJLM; C1; C2; C3; I
    [0]
    [1]
             I + (20 = +)^{"}(( \triangleleft FILM) = CAUCHY[:1]))/iii+\rho CAUCHY
   [2]
             C1 \leftarrow CAUCHY[I:2]
(18)
             C2 \leftarrow CAUCHY[I:3]
₫ [4]
             C3 \leftarrow CAUCHY[I;4]
m [5]
             nen.C1+(C2*(RAVELENGTH*10)*2)+C3*(RAVELENGTH*10)*4
    [0]
             E \leftarrow FERMITTIVITY
ø
    [1]
             E \neq 0 \rho 0
    [2]
             FERMERIME 10f
Ø
    [0]
             PERMPRIME M
<u>ا</u> فا
             FF \leftarrow (N, N) \rho I_1 + 1
             II \leftarrow \forall FF
   [2]
             EE+, ((n[M]+2)-(n0+2))\times(10(01\times(II-FP)\times\ell[M]))\pm01\times II-PP
    [3]
             EEE(0=,(II-\Gamma\Gamma))/(N*2)+((nEM)*2)\times I[M])+(n0*2)\times (1-I[M])
    [4]
    [5]
             E \in E_{\bullet} \subset (\rho II) \rho E E
J
[0]
             KERAVENUMBER
    [1]
             K \in (N,N) \cap k \times i + k \cap
    [2]
             K \leftarrow (\neg K) \times \Pi
             nsestindex wavelength: index; A; ks
    [1]
            n Determine the complex refractive index from 210 to 825 nm.
    [2]
             JNDEX \leftarrow [1+2+(RAVELENGTH \leq ST[;1])/i1+\rho ST
             nsesi[INDEX(1]; 2]+(Ae(WAVELENGTH-SJ[INDEX[1]; 1])] fr/SI[INDEX; 1])
    [3]
    \times -/SI[INDEX;2]
    [5]
             ks+SI(INDEXL1];3]+A×-/SI[INDEX;3]
```

The function COUPLEPRAVE is called by

## COUPLEDNAVE WL

nsens-0J1×ks

where WL is a required argument; its value being the wavelength at which to evaluate the theoretical profile. COUFLEDWAVE, as configured above, is set up to compute TM diffraction. To change to TE, remove the comment symbol from line 26 & 63 and add a comment to line 62. COUPLEDWAVE\_also requires several other variables to be defined in the workspace:

[6]

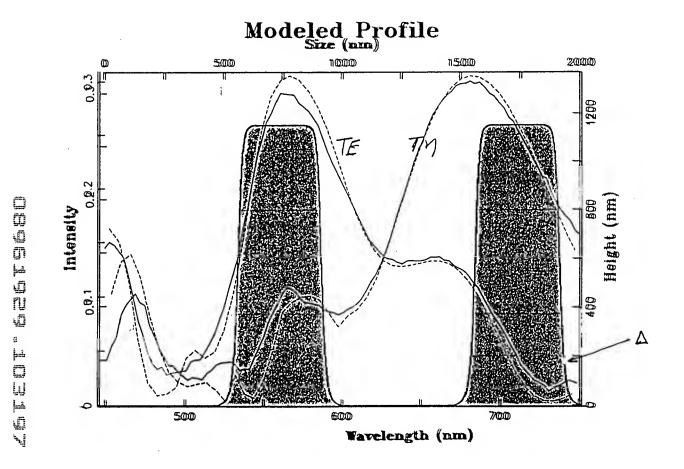


FIG. 12





FIG. 13a

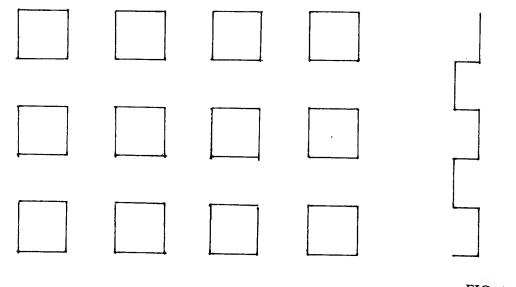


FIG. 13c

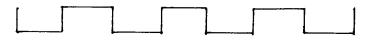


FIG. 13b

CELLICIES LOCAL

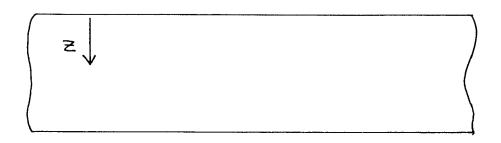


FIG. 14a

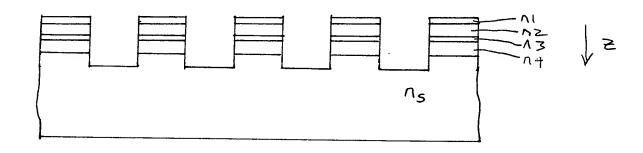


FIG. 14b

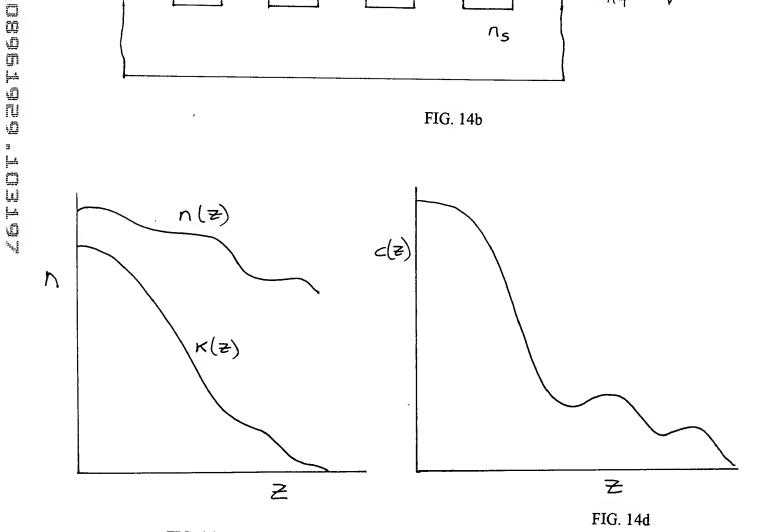


FIG. 14c

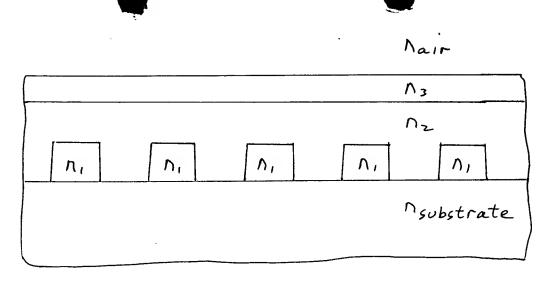


Fig. 15

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